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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Klaus Florian Schuegraf et al.  
Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING POLYCIDE REOXIDATION  
Docket No.: 303.278US1  
Filed: July 30, 1997  
Examiner: O Nadav  
Serial No.: 08/902,809  
Due Date: April 11, 1999  
Group Art Unit: 2811

Assistant Commissioner for Patents  
Washington, D.C. 20231

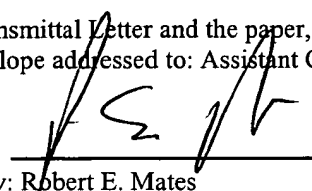
We are transmitting herewith the following attached items (as indicated with an "X"):

- X A return postcard.
- X Amendment and Response (11 Pages).
- X A Supplemental Information Disclosure Statement (1 pgs.), Form 1449 (1 pgs.), and copies of 2 cited references.
- X A check in the amount of \$240.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).
- X Communication Concerning Co-Pending Application (1 pg.).
- X A copy of "Principles of CMOS VLSI Design, A Systems Perspective", by N. Weste, et.al. (4pgs.)
- X A copy of "The Design and Analysis of VLSI Circuits", by L. Glasser, et. al. (12pgs.)

**Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.**

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described above, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this 9th day of April, 1999.

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By:   
Atty: Robert E. Mates  
Reg. No. 35,271

(GENERAL)

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